

**EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<p style="text-align: center;"><b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b></p> <p style="text-align: center;">(PTO-1449)</p> <p style="text-align: right;">   <small>SEARCH &amp; TRADEMARK OFFICE</small> </p>		<p>ATTY. DOCKET NO. 007720 USA/ FPS/MMCS/APC</p> <p>SERIAL NO. 10/632,107</p>
<p>APPLICANT Alexander T. SCHWARM et al.</p>		
<p>FILING DATE August 1, 2003</p>		<p>GROUP 2812</p>
<p><b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b></p>		
<p>IslamRaja, M. M., C. Chang, J. P. McVittie, M. A. Cappelli, and K. C. Saraswat. May/June 1993. "Two Precursor Model for Low-Pressure Chemical Vapor Deposition of Silicon Dioxide from Tetraethylorthosilicate." <i>J. Vac. Sci. Technol. B</i>, Vol. 11, No. 3, pp. 720-726.</p>		
<p>Kim, Eui Jung and William N. Gill. July 1994. "Analytical Model for Chemical Vapor Deposition of SiO<sub>2</sub> Films Using Tetraethoxysilane and Ozone" (Abstract). <i>Journal of Crystal Growth</i>, Vol. 140, Issues 3-4, pp. 315-326.</p>		
<p>Guo, R.S, A. Chen, C.L. Tseng, I.K. Fong, A. Yang, C.L. Lee, C.H. Wu, S. Lin, S.J. Huang, Y.C. Lee, S.G. Chang, and M.Y. Lee. June 16-17, 1998. "A Real-Time Equipment Monitoring and Fault Detection System." <i>Semiconductor Manufacturing Technology Workshop</i>, pp. 111-121.</p>		
<p>Lantz, Mikkel. 1999. "Equipment and APC Integration at AMD with Workstream." <i>IEEE</i>, pp. 325-327.</p>		
<p>July 15, 2004. Office Action for U.S. Serial No. 10/172,977, filed June 18, 2002.</p>		
<p>August 2, 2004. Office Action for U.S. Serial No. 10/174,377, filed June 18, 2002.</p>		
<p>August 9, 2004. Written Opinion for PCT Serial No. PCT/US02/19063.</p>		
<p>August 18, 2004. International Preliminary Examination Report for PCT Serial No. PCT/US02/19116.</p>		
<p>August 24, 2004. Office Action for U.S. Serial No. 10/135,405, filed May 1, 2002.</p>		
<p>August 25, 2004. Office Action for U.S. Serial No. 09/998,384, filed November 30, 2001.</p>		
<p>September 9, 2004. Written Opinion for PCT Serial No. PCT/US02/21942.</p>		
<p>September 16, 2004. International Preliminary Examination Report for PCT Serial No. PCT/US02/24859.</p>		
<p>EXAMINER</p>		<p>DATE CONSIDERED</p> <p style="text-align: right;"><i>sfstos</i></p>

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October 1, 2004. International Preliminary Examination Report for PCT Serial No. PCT/US03/23964.

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September 29, 2004. Office Action for U.S. Serial No. 09/363,966, filed July 29, 1999.			
October 1, 2004. International Preliminary Examination Report for PCT Serial No. PCT/US03/23964.			
October 6, 2004. Office Action for U.S. Serial No. 10/759,108, filed January 20, 2004.			
October 12, 2004. International Preliminary Examination Report for PCT Serial No. PCT/US02/19061.			
November 17, 2004. Written Opinion for PCT Serial No. PCT/US01/27407.			
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